



## Laser-Assisted Micro- and Nano-Fabrications

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### Message from the Guest Editor

Laser-based micro/nano-manufacturing technologies have emerged in recent years to address relevant issues to increase laser applicability to virtually all kinds of materials at scales down to nanometers. The aim of this Special Issue is to provide an overview of the latest laser techniques developed during these 60 years, categorized into four main areas:

1. Near field laser fabrications
2. Far field laser interference lithography and laser direct writing for micro and nano fabrication
3. Laser manufacturing of nano materials
4. Stimulated-emission-induced depletion (STED)-assisted laser fabrication.





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